



AF/1/1 JFW

AMENDMENT TRANSMITTAL LETTER			Docket No. SON-2010	
Application No. 09/772,986-Conf. #2637	Filing Date January 31, 2001	Examiner T. F. Tran	Art Unit 2811	
Applicant(s): Hisao Hayashi et al.				
Invention: THIN FILM SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF				
<b>TO THE COMMISSIONER FOR PATENTS</b>				
Transmitted herewith is an amendment in the above-identified application.				
The fee has been calculated and is transmitted as shown below.				
<b>CLAIMS AS AMENDED</b>				
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
Total Claims	2	- 20 =		x
Independent Claims	2	- 3 =		x
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify): Request for Oral Hearing				300.00
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>				
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input type="checkbox"/> No additional fee is required for this amendment.				
<input checked="" type="checkbox"/> Please charge Deposit Account No. 18-0013 in the amount of \$ _____ A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.				
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 18-0013 as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
_____ Ronald P. Kananen Attorney Reg. No.: 24,104			Dated: December 6, 2004	
RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750				



Docket No.: SON-2010  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Hisao Hayashi et al.

Application No.: 09/772,986

Confirmation No.: 2637

Filed: January 31, 2001

Art Unit: 2811

For: THIN FILM SEMICONDUCTOR DEVICE  
AND MANUFACTURING METHOD  
THEREOF

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Examiner: T. F. Tran

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Appeal Brief - Patents  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated March 12, 2004, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.